







Probing magnetism in atomically thin semiconducting PtSe₂

Ahmet Avsar ^{1,2,4}✉, Cheol-Yeon Cheon^{1,2,4}, Michele Pizzochero ^{3,4}, Mukesh Tripathi ^{1,2}, Alberto Ciarrocchi ^{1,2}, Oleg V. Yazyev ³ & Andras Kis ^{1,2}✉

Atomic-scale disorder in two-dimensional transition metal dichalcogenides is often accompanied by local magnetic moments, which can conceivably induce long-range magnetic ordering into intrinsically non-magnetic materials. Here, we demonstrate the signature of long-range magnetic orderings in defective mono- and bi-layer semiconducting PtSe₂ by performing magnetoresistance measurements under both lateral and vertical measurement configurations. As the material is thinned down from bi- to mono-layer thickness, we observe a ferromagnetic-to-antiferromagnetic crossover, a behavior which is opposite to the one observed in the prototypical 2D magnet CrI₃. Our first-principles calculations, supported by aberration-corrected transmission electron microscopy imaging of point defects, associate this transition to the interplay between the defect-induced magnetism and the interlayer interactions in PtSe₂. Furthermore, we show that graphene can be effectively used to probe the magnetization of adjacent semiconducting PtSe₂. Our findings in an ultimately scaled monolayer system lay the foundation for atom-by-atom engineering of magnetism in otherwise non-magnetic 2D materials.

¹Electrical Engineering Institute, École Polytechnique Fédérale de Lausanne (EPFL), Lausanne 1015, Switzerland. ²Institute of Materials Science and Engineering, École Polytechnique Fédérale de Lausanne (EPFL), Lausanne, CH 1015, Switzerland. ³Institute of Physics, École Polytechnique Fédérale de Lausanne (EPFL), Lausanne, CH 1015, Switzerland. ⁴These authors contributed equally: Ahmet Avsar, Cheol-Yeon Cheon, Michele Pizzochero. ✉email: ahmet.avsar@epfl.ch; andras.kis@epfl.ch

Two-dimensional (2D) transition metal dichalcogenides (TMDCs)¹ are emerging as an appealing class of materials for a wide range of research topics¹, including electronics², spintronics^{3–6}, and magnetism^{7–10}. Among this rapidly expanding family of materials, layered platinum diselenide (PtSe₂) is a relatively new and interesting member due to its unique thickness-dependent electronic structure^{11–17}. While multilayer films exhibit metallic character, this crystal undergoes a metal-to-semiconductor transition when thinned down to mono- and bilayers^{11–13}. Theoretical work has also indicated that electronic properties of such thin PtSe₂ crystal can be further tuned by defect engineering¹⁸.

Recent experimental investigations highlighted a broad variety of intrinsic point defects in PtSe₂¹⁹. Even though imperfections are often regarded as detrimental to material properties, in many cases their presence has proven successful in introducing functionalities that would otherwise be absent in pristine materials^{20,21}. This is especially true in the case of metallic PtSe₂ multilayers, where surface Pt vacancies trigger a thickness-dependent surface magnetic ordering^{18,20}. The strength of the magnetic exchange coupling across the metallic multilayers is governed by the RKKY interactions. However, thin films of PtSe₂ acquire a semiconducting character when approaching the single-layer regime^{11,13}, and the physical picture governing the magnetic exchange interactions in the thinnest films of PtSe₂ would rather invoke the direct and superexchange mechanisms, similarly to dilute magnetic semiconductors²². Understanding and controlling the interplay between disorder and magnetism in this ultimate thickness scale can spark unexplored directions for designing 2D semiconducting magnets through defect engineering⁸. In this Letter, we demonstrate that defect-induced magnetism is preserved in mono and bilayers of semiconducting PtSe₂, with a monolayer, surprisingly, showing antiferromagnetic ordering, while bilayer PtSe₂ is a ferromagnet.

Results

Device characterization. Our ultra-thin PtSe₂ flakes were obtained by mechanical exfoliation from CVT-grown bulk crystals (HQ Graphene), and their thicknesses were determined by atomic force microscopy (AFM). As shown in Fig. 1a, the thickness of a monolayer (bilayer) is found to be ~0.65 nm (~1.2 nm). Next, the mono- or bilayer crystal was transferred onto a monolayer graphene ribbon which was initially deposited onto a Si/SiO₂ substrate. Graphene is utilized as a bottom electrode, thereby taking advantage of its electrostatic transparency. This enables gate-tunable vertical and lateral transport operations, as the screening length exceeds its monolayer thickness²³. By employing electron-beam lithography and electron-beam evaporation techniques, non-magnetic metallic palladium (Pd) contacts (80-nm thick) were formed on top of PtSe₂ and graphene. Further details concerning the device fabrication process are given in “Methods” section. The choice of non-magnetic graphene and Pd contacts rules out any influence of the electrodes on the magnetic response of the device. The schematics of the resulting device geometry is shown in Fig. 1c. This geometry allows us to probe the magnetism in PtSe₂ through vertical transport by passing the charge current between electrodes #2 (graphene) and #3 (Pd). In addition, it allows us to characterize the basic transport properties of monolayer PtSe₂ by utilizing Pd electrodes #3 and #4 in the lateral measurement geometry. We further compare the magneto-transport properties of isolated graphene as well as the graphene/monolayer PtSe₂ heterostructure by relying on electrode pairs #1 & #2 and #2 & #5, respectively. An optical image of the completed device is presented in the bottom panel of Fig. 1c. The transport output was

characterized as a function of back-gate voltage (V_{BG}), source-drain bias (V_{DS}), magnetic field, and temperature. Magnetic field-dependent measurements were performed at the base temperature (1.6 K) to maximize the signal-to-noise ratio.

Charge transport in monolayer PtSe₂. Prior to magnetic field-dependent measurements, we first assess the basic charge transport properties of monolayer PtSe₂. Figure 1d shows the V_{BG} dependence of I_{DS} measured at temperatures covering the 1.6–142 K range, while maintaining a constant $V_{DS} = 2$ V. While I_{DS} is slightly modulated by the application of V_{BG} due to the semiconducting nature of monolayer PtSe₂, the device shows a relatively low on-state conductance ($V_{BG} > -5$ V). The insulating nature of the crystal is unambiguously confirmed by the observed temperature dependence of the conductivity (σ) measured at fixed carrier concentrations (Fig. 1e-Inset). In the presence of disorder, the electrical transport can be described using the Mott formalism and the variable range hopping (VRH) model which describes the conductivity σ in terms of a characteristic temperature²⁴. The observed linear dependence of the $\ln(G)$ on $T^{-1/3}$ at different given carrier densities (see Fig. 1e and Supplementary Note 1) supports the 2D VRH nature of charge transport up to room temperature (RT). Such a characteristic temperature dependence has been widely observed in many systems, including defective 2D TMDC monolayers^{25–27}. In fact, a bandgap of 1.2 eV is expected in monolayer PtSe₂¹² which in turn should result in a stable off state over a large V_{BG} range even at RT. For example, transport characteristics of monolayer black phosphorus²⁸ and multilayer MoSe₂²⁹, which display comparable bandgap values with monolayer PtSe₂, exhibit a stable off-state over 60 V when measured in a back-gate device geometry with an equivalent SiO₂ thickness of ~270 nm. As shown in Fig. 1f, the lack of a clear off-state along with a strong dependence of the off-current on V_{DS} at RT signals the hopping nature of charge transport, and, importantly, further suggests the presence of atomic defects in monolayer PtSe₂²⁷.

Imaging PtSe₂ defects using transmission electron microscopy. In order to directly visualize the type of defects in our samples, we relied on Cs-corrected high-resolution transmission electron microscopy imaging. The result obtained from a bilayer PtSe₂ with a low accelerating voltage of 80 kV is shown in Fig. 1b. Consistent with early scanning tunneling microscopy investigations¹⁹, we observe native Se and Pt vacancies in ultra-thin PtSe₂ films. The concentration of Pt vacancy defects is found to be $\sim 9 \times 10^{12} \text{ cm}^{-2}$ (see Supplementary Note 2). Similarly to the bilayer case, we also observe Pt vacancies in monolayers (see Supplementary Note 3).

Magneto-resistance measurement in monolayer PtSe₂. After confirming the presence of intrinsic defects in our crystals, we next study the magneto-transport characteristics of our monolayer PtSe₂ sandwiched between the source (graphene) and drain (Pd) electrodes (inset of Fig. 2a) by utilizing a vertical measurement geometry. A fixed V_{DS} is applied to PtSe₂ while measuring the dependence of device resistance on the applied magnetic field. As shown in Fig. 2a, the I_{DS} - V_{DS} curve is nearly linear and symmetric, measured at zero field. As compared to the lateral transport measurement shown in Fig. 1d, the device resistance under vertical geometry is improved by several orders of magnitude, as a result of the reduced transport pathway. Such a highly conductive response obtained along the vertical direction allows us to probe directly the magnetic ordering of monolayer PtSe₂. To this end, we sweep the out-of-plane magnetic field from -0.2 to 0.2 T while recording the vertical device resistance at

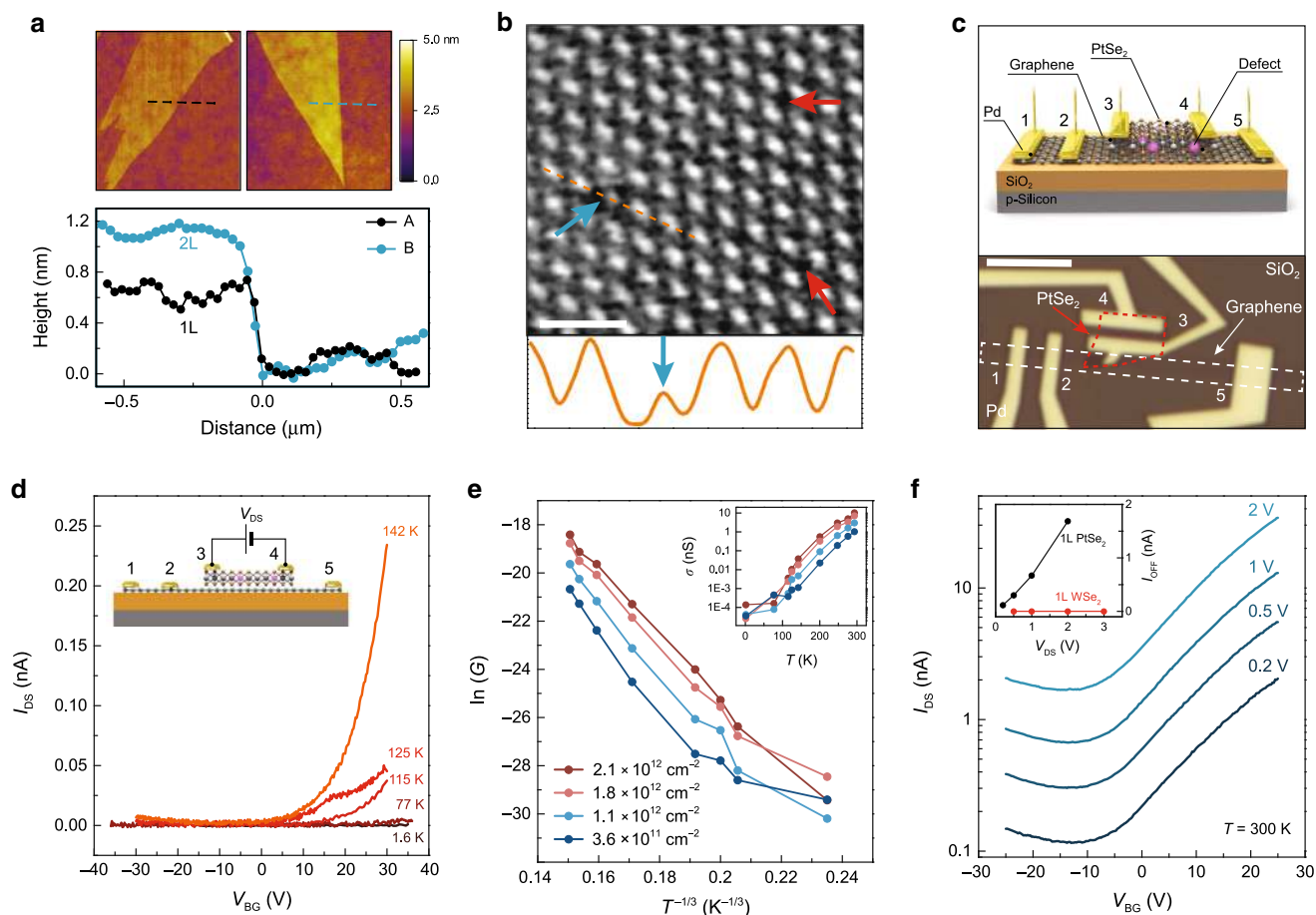


Fig. 1 Device structure and basic characterization. **a** AFM images for mono- and bilayer PtSe₂ which are utilized as active channel materials in characterized devices. Color scale of the AFM image is 0–5 nm. Following the dashed lines, a height of ~0.65 nm (~1.2 nm) is measured for monolayer (bilayer) PtSe₂. Scan size: ~3 μm × 3 μm. **b** Raw HAADF image of a bilayer PtSe₂. Blue and red arrows show the sites with missing Pt and Se atoms, respectively. Scale bar is 1 nm. Bottom panel shows the intensity profile measured along the dashed orange line shown in the STEM image. Blue arrow shows the intensity recorded at the Pt vacancy site. **c** Top panel: device schematics. A few layer thick PtSe₂ with intrinsic defects is transferred on top of monolayer graphene. Both graphene and PtSe₂ are contacted with non-magnetic Pd contacts (80-nm thick). Bottom panel: optical image of a completed device. Scale bar is 6 μm. **d** V_{BG} dependence of I_{DS} measured at fixed temperature values. V_{DS} = 2 V. Inset shows the device schematic. **e** ln(G) vs T^{-1/3} measured at different doping levels. Inset shows the temperature dependence of device conductance at different doping values. **f** Room-temperature V_{BG} dependence of I_{DS} measured at fixed V_{DS} values. Inset compares the V_{DS} dependence of measured off-state conductance for monolayer PtSe₂ and WSe₂ prepared under the same conditions.

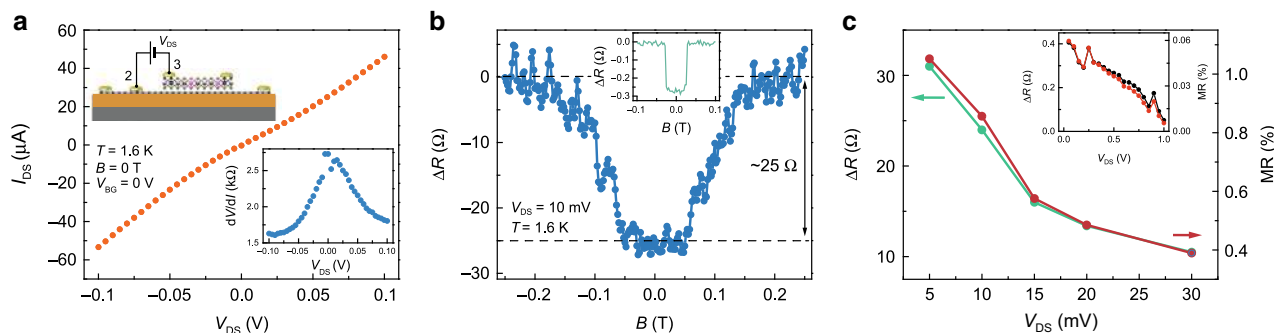


Fig. 2 Vertical transport across monolayer PtSe₂. **a** Bias voltage dependence of I_{DS}. Top inset is the schematic of the measurement geometry. Bottom inset is the differential resistance as a function of applied bias. **b** Magnetic field dependence of electrical resistance measured at T = 1.6 K. The observation of a two-plateau response indicates the presence of antiferromagnetic ground-state ordering. Inset shows the magneto-transport measurements for a ~7-nm-thick metallic PtSe₂. **c** Bias dependence of the change in device resistance as a result of the magnetic field and corresponding MR percentage. All measurements are taken at 1.6 K. Inset shows the bias dependence of resistance and MR for a ~7-nm-thick metallic PtSe₂.

$V_{DS} = 10$ mV. As clearly seen in Fig. 2b, the evolution of the resistance in our device with the magnetic field substantially departs from the typical localization response. Indeed, it features plateaus with two different values. As the field is increased, the lower plateau observed in the -50 mT $< B < 50$ mT interval is found to slowly approach the high plateau observed above 150 mT. This two-plateau response is the signature of an anti-ferromagnetic ground-state ordering^{20,30,31}. While we find a similar two-plateau response in thicker films of PtSe₂ (inset of Fig. 2b), the observation of a slow low-to-high plateau switching in monolayer PtSe₂ indicates that the magnetic moments are not fully oriented along the out-of-plane direction, with spins that could be slightly canted. Similarly to metallic films, hysteresis in monolayer PtSe₂ is almost absent (see Supplementary Note 4). Furthermore, the magnetoresistance (MR) percentage is found to be bias-dependent as in thicker metallic devices and estimated to be 1% in the low-bias regime (Fig. 2c).

In order to investigate the impact of magnetic ordering in PtSe₂ on the transport properties of graphene, we characterize the graphene device resistance with and without PtSe₂ on the channel connecting the source and drain electrodes. Figure 3a displays the V_{BG} dependences of corresponding device resistances which show nearly identical device characteristics. However, the magnetic field responses of these junctions present striking differences, as shown in Fig. 3b, c. While the pristine graphene junction exhibits a conventional weak localization response³², the junction with the PtSe₂ monolayer exhibits plateaus with two different values^{20,30,31}. This difference in the magneto-transport properties is clearly due to the presence of magnetism in PtSe₂ and could be ascribed to two possible origins. One possibility is the back-and-forth hopping of graphene's electrons through the magnetic defect states in PtSe₂ via quantum tunneling, a mechanism similar

to the previously reported one in graphene/WS₂ heterostructures³³. This possibility is indeed supported by the observation of linear $I_{DS}-V_{DS}$ relation and the nearly identical shapes of the magnetic response of pure PtSe₂ and the graphene/PtSe₂ heterostructure, as shown in the inset of Fig. 3c. On the other hand, there could be contribution from the interface-induced magnetism³⁴ by PtSe₂.

Magnetoresistance measurement in bilayer PtSe₂. Finally, we complement our investigation by replacing monolayer PtSe₂ with bilayer PtSe₂. We observe a hysteresis loop with minima at ± 15 mT under backward and forward scans (Fig. 3d), which is the hallmark of ferromagnetism³⁵. The maximum change in the device resistance upon the application of a magnetic field is ~ 16 Ω and it strongly depends on the applied V_{DS} . The MR percentage probed by graphene is $\sim 0.1\%$ and is nearly independent of the applied V_{BG} (see Supplementary Notes 5–6). Our findings suggest that monolayer (bilayer) PtSe₂ exhibits long-range anti-ferromagnetic (ferromagnetic) ground-state ordering, and that adjacent graphene electrodes can effectively be used as a sensitive probe to detect such magnetism³⁶. To shed more light on this anti-ferromagnetic-to-ferromagnetic crossover, measurement techniques such as single-spin microscopy³⁷ can be employed at the nanoscale in future experiments. Such direct measurements would unambiguously determine the types of magnetism and its strength, as recently utilized for another layered magnet³⁷.

Long-range magnetic ordering in semiconductors can be achieved through the incorporation of extrinsic magnetic impurities (e.g., Mn-doped GaAs³⁸ and V-doped WSe₂³⁹). We rule out this possibility in our work by performing quantitative and qualitative assessment of our samples, which do not show the

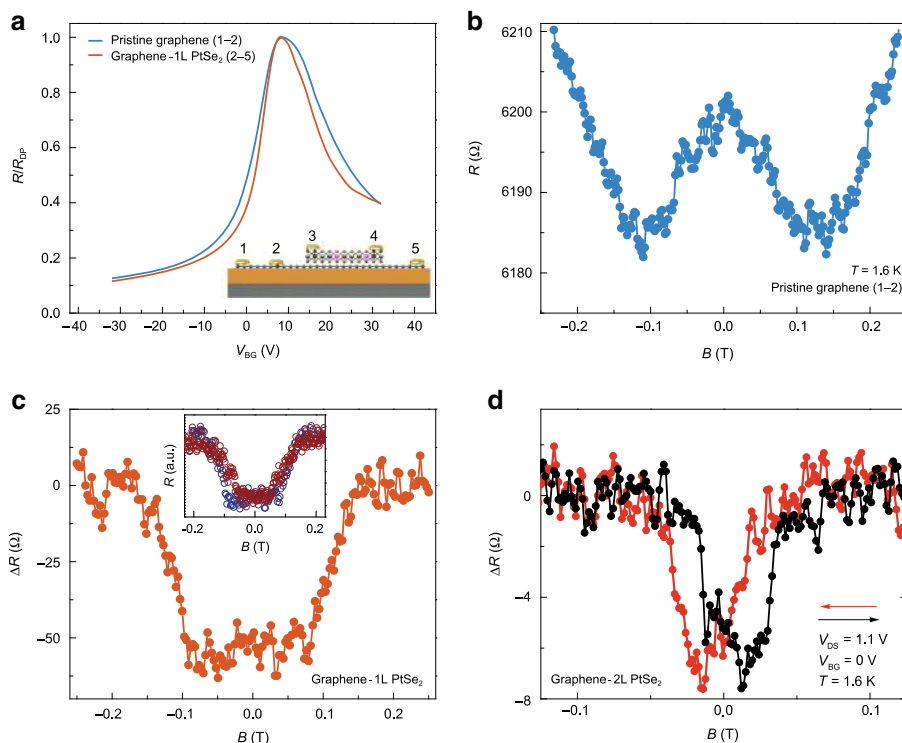


Fig. 3 Induced magnetization in monolayer graphene. **a** V_{BG} dependence of graphene resistance. Red (blue) line represents the device with (without) a monolayer PtSe₂ on top of the graphene channel, between the voltage probes. Inset is the schematics of the measurement geometry. **b** Magnetic field dependence of pristine graphene resistance measured at $T = 1.6$ K. **c** Magnetic field dependence of graphene resistance measured at $T = 1.6$ K for the device with monolayer PtSe₂ on the channel. Inset shows the magnetic field response of vertically measured monolayer PtSe₂ (red circles) and laterally measured graphene/monolayer PtSe₂ (blue circles). They have similar out-of-plane coercive fields. **d** Magnetic field dependence of graphene resistance measured at $T = 1.6$ K for the device with a bilayer PtSe₂ on the graphene channel. Arrows represent magnetic field sweep directions.

presence of any chemical elements except for Pt and Se and other crystal phases beside 1T (see Supplementary Notes 7 and 8). Therefore, our findings constitute a model study demonstrating the purely defect-induced magnetism into an otherwise non-magnetic crystal down to the ultimately scaled monolayer system.

First-principles calculations. We now address the physical mechanism underlying the observed effects from a theoretical perspective. According to a purely ionic argument, Pt atoms exhibit a formal oxidation state of +4 and a resulting valence electron configuration $5d^66s^0$. On the basis of the crystal and ligand fields associated with the octahedral environment in which each Pt atom resides, a splitting of the d orbitals into a pair of empty e_{2g} states and fully occupied t_{2g} states is expected. Such a full occupation of the t_{2g} manifold prevents any intrinsic magnetism in PtSe₂ at all possible thicknesses, from monolayer to bulk, as further confirmed by our explicit density-functional calculations. As in the case of metallic PtSe₂²⁰, we conclude that lattice imperfections are the origin of the observed layer-dependent magnetism in semiconducting PtSe₂. Motivated by direct observation of Pt vacancies in our transmission electron microscope images shown in Fig. 1b, their indirect inference from our charge transport measurements as well as earlier scanning tunneling microscopy studies¹⁹, we investigate electronic and magnetic properties of mono- and bilayer models of PtSe₂ with platinum vacancy defects by means of first-principles calculations. For the monolayer case, we find that a Pt vacancy defect in its fully spin-polarized configuration gives rise to a local magnetic moment of $4.00 \mu_B$, which is localized mostly on the six selenium atoms neighboring to the missing Pt atom. We note, however, that the configuration characterized by local magnetic moments in the two Se atomic planes that are oriented antiparallel to each other (Fig. 4a) is 35 meV lower in energy than the former parallel configuration. Below, we will refer to this configuration with zero net magnetic moment as antiferromagnetic. Here, we would like to also note that the Se point defect does not lead to magnetism.

Next, we consider the bilayer PtSe₂ model with Pt vacancy in one of the two layers. In contrast to the monolayer case discussed above, we could not identify any solution for a defective bilayer other than the ferromagnetic configuration with a net magnetic moment of $1.33 \mu_B$ (Fig. 4b). This value agrees well with the one obtained for Pt vacancy defects in thicker metallic PtSe₂ slabs²⁰. The reason for this traces back to the existence of interlayer coupling between the PtSe₂ sheets in the bilayer system. In our previous work²⁰, we have shown that platinum vacancy defects located at the surfaces of multilayer PtSe₂ act as magnetic centers, while their presence in the inner regions of the thick samples (as well as in the three-dimensional bulk material) does not lead to any local magnetic moment. This observation clearly pinpoints the pivotal role of interlayer interactions in quenching the defect-induced magnetic response in PtSe₂. In bilayer PtSe₂, the interlayer coupling affects only one of the two selenium atomic planes. As a result, the defect-induced magnetic moment in this system is reduced ($1.33 \mu_B$) as compared to the fully polarized magnetic moment of defect in monolayer PtSe₂ ($4.00 \mu_B$), and, remarkably, the spin density primarily resides on the outmost selenium atoms in the defect (Fig. 4b). Overall, our first-principles calculations suggest that a platinum vacancy defect yields an antiferro- (ferro-)magnetic ordering in mono (bi-)layer PtSe₂, thereby portraying a theoretical picture in accord with our experimental observations.

Discussion

Antiferromagnets have been recently considered for sensing and memory applications⁴⁰. For this purpose, layered intralayer

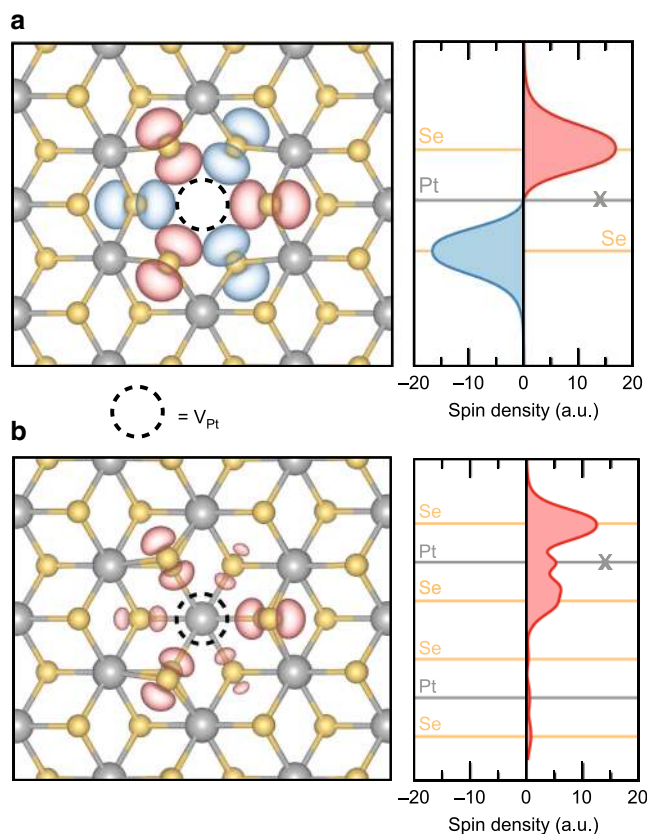


Fig. 4 Localized magnetic moments at Pt vacancy defects in PtSe₂.

a Spin-density distribution at the ground-state configuration of the V_{Pt} defect in monolayer PtSe₂ calculated from first principles. Gray and orange balls represent Pt and Se atoms, respectively. The red and blue isosurfaces correspond to positive and negative spin densities. The position of the missing Pt atom is marked with a dashed circle. The right panel shows the in-plane averaged spin density as a function of the out-of-plane position. The cross (X) indicates the Pt atomic plane at which the vacancy defect is introduced. **b** Spin-density distribution at the Pt vacancy in the top layer of bilayer PtSe₂ calculated from first principles. Units in panels (a) and (b) agree with each other.

antiferromagnetic compounds such as MnPS₃, FePS₃, and CoPS₃ indeed show promise⁹. Among these, only a few of them have been exfoliated down to the monolayer. While antiferromagnetic ordering at the monolayer limit still persists in FePS₃ with an unchanged transition temperature⁴¹, such ordering is suppressed in NiPS₃⁴². Unlike FePS₃, the observed antiferromagnetic ordering in monolayer PtSe₂ is not intrinsic, rather originates from native impurities hosted in the material. Therefore, our work ignites the potential of atomic-scale defects for driving non-magnetic 2D crystals into magnetic phases, thereby opening new directions for expanding the library of two-dimensional magnets⁴³.

Methods

Device fabrication. Our device fabrication starts with the mechanical exfoliation of monolayer graphene nanoribbons onto a doped Si substrate with 270 nm of SiO₂. PtSe₂ crystals are similarly obtained by the mechanical exfoliation from bulk crystals (HQ Graphene) onto a Si/SiO₂ wafer. The thickness of selected crystals was determined by using AFM topography imaging (Asylum Research Cypher). PtSe₂ was then isolated from its Si/SiO₂ substrate with the help of a supporting PMMA layer by etching SiO₂ via a diluted potassium hydroxide (KOH) solution (0.7%, ~3 h). This was followed by rinsing the isolated film in deionized (DI) water for several times prior to its transfer onto previously exfoliated graphene nanoribbons. After removing the supporting PMMA via a hot acetone treatment (~90 °C for 1 h)

followed by cleaning with IPA. The resulting graphene/PtSe₂ heterostructure was annealed at 250 °C for 6 h under high vacuum conditions ($\sim 1 \times 10^{-6}$ mbar) to further remove the transfer-related residues. Metallic contacts were prepared using e-beam lithography (Raith EBPG 5000+, 100 keV thermal field emission gun with an e-beam dose of $\sim 950 \mu\text{C}/\text{cm}^2$) and e-beam evaporation of Pd (Alliance-Concept EVA 760, 80-nm thick). The deposition rate of Pd is 1 Å/s under the base pressure of $\sim 1 \times 10^{-6}$ mbar.

Transport measurements. Cryogenic measurements were performed in an ICE Oxford liquid helium continuous flow cryo-magnetic system with a base temperature of ~ 1.5 K. Source-drain currents were measured using a Keithley source-cemeter 2636B, while a Keithley source-cemeter 2400 was used for applying bias through the SiO₂ gate dielectric. The source voltage was varying between 0 and 2 V, while the drain was grounded.

Electron microscopy sample preparation and imaging. After the identification of 1–3 layers of PtSe₂ on Si/SiO₂ substrate using AFM, the substrate was spin-coated with a PMMA A2 polymer (1500 rpm, ~ 150 -nm thick) and baked on a hot plate at 60 °C for 4 min. Then, PMMA surrounding the target PtSe₂ was scratched and detached after mildly etching SiO₂ using a dilute KOH solution (0.7%, ~ 30 min). The floating PMMA A2 film was picked up and rinsed several times in DI water. Finally, the film was aligned on Si₃N₄ TEM grids with the help of a micro-manipulator using a glass nanocapillary. Supporting PMMA film was removed by using the cleaning protocol discussed above. Resulting crystals on TEM grids were annealed at 250 °C for 6 h under high vacuum conditions ($\sim 1 \times 10^{-6}$ mbar) to further remove the transfer-related residues. Here, we note that a very diluted KOH concentration is used to eliminate the unintentional creation of defects in PtSe₂. This effective transfer process was previously utilized for the STEM imaging of graphene, MoS₂, and WS₂ crystals which have extremely low concentration of defects.

Scanning transmission electron microscopy (STEM) imaging experiments were conducted using an aberration-corrected (with double Cs corrector) FEI Titan Themis TEM 60–300 kV, equipped with Schottky X-FEG electron source and a monochromator to reduce the effect of chromatic aberrations. To minimize the effect of electron-beam-induced knock-on damage, a low acceleration voltage (80 kV) was used for all the experiments. The typical electron probe current was 20 pA. Images were acquired with Gatan high annular angular dark-field (HAADF) detector using 185-mm camera length which corresponds to a 49.5–198 mrad collection angle.

TEM simulations. Multislice STEM image simulations were performed using the Dr. Probe software package⁴⁴. The frozen phonon method was used with 30 variations per pixels and 64 displacements per atom. The resulting sampling rate was ~ 0.02 nm/pixel. The simulation parameters were chosen to be similar to the experimental conditions. The beam semi-convergence angle and HAADF detector angle was set to 21.2, 49.5–198 mrad, respectively. The source size was chosen to 0.05 nm and all the aberrations were set to zero. The result of STEM image simulation confirms that there is no degradation or structural modification of PtSe₂ in the process of transfer (see Supplementary Note 9).

First-principles calculations. Our calculations were performed under the gradient-corrected, spin-orbit inclusive density-functional theory formalism, as implemented in VASP^{45,46}. We treated the exchange and correlation effects at the PBE level⁴⁷, but additionally verified the robustness of our results against the choice of the density functional (see Supplementary Note 10). The energy cutoff for the plane wave basis set was set to 500 eV. The integration over the Brillouin zone was carried out with the equivalent of $12 \times 12 \times 1$ k-points per unit cell. These parameters were chosen after extensive convergence tests. During the geometry optimizations, the in-plane lattice constants and interlayer spacing for the bilayer systems were constrained to their experimental values of 3.73 and 5.08 Å, respectively, while atomic coordinates were relaxed until each residual component on the Hellmann–Feynman forces was lower than $0.01 \text{ eV } \text{Å}^{-1}$. We modeled defective mono and bilayer PtSe₂ by introducing a single Pt vacancy defect in an otherwise pristine 4×4 supercell containing 48 and 96 atoms, respectively, as such models host a Pt vacancy concentration of $14 \times 10^{12} \text{ cm}^{-2}$, very close to our experimental estimate of $\sim 9 \times 10^{12} \text{ cm}^{-2}$. In Supplementary Note 10, we additionally show that our conclusions are insensitive to the size of the supercell. A vacuum region of 15 Å was introduced to separate the periodic images.

Data availability

The data that support the findings of this study are available from the corresponding author on reasonable request.

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Author contributions

A.A. and A.K. designed the experiments. A.A., C.-Y.C., and A.C. fabricated the samples and performed transport measurements. M.T. performed TEM imaging and simulations. M.P. and O.V.Y. devised models and performed first-principles calculations. A.A., M.P., and A.K. wrote the paper with input from all authors.

Competing interests

The authors declare no competing interests.

Additional information

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Correspondence and requests for materials should be addressed to A.A. or A.K.

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